

Appl. No. 09/754,264
Amendment and/or Response
Reply to Office Action of November 19, 2004

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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

Appl. No.: 09/754,264

Applicant(s): Tetsuo Usami, et al.

Filed: January 5, 2001

TC/A.U.: 2800/2814

Examiner: S.H. Rao

Atty. Docket: OKI.202

Title: Deposition Method For Wiring

Thin Film

**CERTIFICATE OF MAILING OR
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On: March 19, 2004

By: 
William S. Francos

AMENDMENT and/or RESPONSE under 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of November 19, 2003, please amend the
above referenced application as follows and reconsider the application in light of the
following remarks.

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This paper includes (each beginning on a separate sheet):

- 1. Amendments to the claims** reflected in the complete listing of the claims, which begins on page 3 of this paper; and
- 2. Remarks/Discussion of issues**, which begin on page 6 of this paper;

Atty. Docket No. **OKI.202**